

# MetPrep Preparation Procedure – No 154



## New Generation Ceramic Machine Tool

	Surface	Abrasive	Pressure		Speed – Dir	Time
Primary Grinding Stage	Fixed Diamond	40 µm MB	Psi	N	500 – Comp	Until Planar
			5	25		

	Surface	Abrasive	Pressure		Speed – Dir	Time
Additional Grinding Stages	Abracloth	9 µm (WB) PCD Diamond	Psi	N	250 – Comp	5 mins
			5	25		
	Planocloth	3 µm (WB) PCD Diamond	5	25	250 – Comp	6 mins

	Surface	Abrasive	Pressure		Speed – Dir	Time
Polishing Stage	Planocloth	0.06 µm Silco	Psi	N	100 – Contra	6 mins
			5	25		